

Brief Report

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Article

Finding Transmittance Spectrum Envelopes for Optical Characterization of Thin Solid Films

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Abstract: We propose a novel optimization approach for determining the envelopes of thin-film transmittance spectra. This method can be coupled with the Swanepoel algorithm to determine the optical properties of the thin films.

Keywords: Thin solid films; Spectroscopy; Swanepoel method; Envelopes; Optical Properties; Optimization

Thin solid films are essential in modern technologies, including metal coatings for protection or applications in the dielectric and semiconductor industries (such as transistors and photodiodes). Precisely determining their optical functions, specifically the refractive index (n) and the attenuation coefficient (k), is fundamental for understanding their opto-electrical properties. The continuous pursuit of improved properties leads to the development of advanced new-generation technologies. For instance, significant progress has been made in the creation of more efficient optical sensors and solar energy cells [1].

In order to perform the optical characterization, the thin films are often deposited on a transparent glass substrate (see Figure 1a) with known optical properties, $n_s(\lambda) \approx \text{const}$ and $k_s(\lambda) \approx 0$. Spectroscopic measurements provide a reliable method for determining the optical functions of thin films across a wide spectral range, usually within the UV-VIS-NIR region. Specifically, normal-incidence transmission spectroscopy stands out as a cost-effective and straightforward alternative [2]. The transmittance ($T = I/I_0$), defined as the ratio of transmitted to input intensity, is plotted for different wavelengths in Figure 1b.

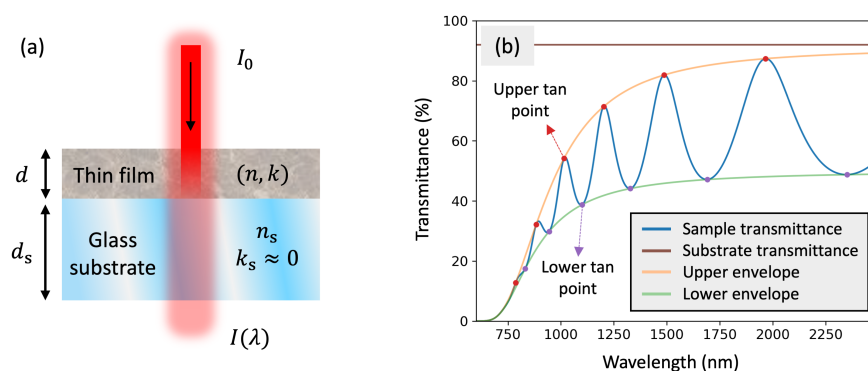


Figure 1. (a) Scheme of the transmission spectroscopy experiment. (b) Transmittance spectrum and envelopes.

The Swanepoel Method [3–5] enables the determination of the two optical functions, but only at specific discrete wavelengths known as tangent points, λ_{tan}^i , for $i = \{1, 2, \dots\}$. By definition, these tangent points are the intersections of the transmission spectra with its upper and lower envelopes. These points satisfy the Fabry-Perot interference formulas, $2n(\lambda_{\text{tan}}^i)d = m^i \lambda_{\text{tan}}^i$, where d is the film

thickness and m^i are integers for the upper points and half-integers for the lower points. Thus, tangent points correspond to wavelengths of completely constructive and destructive interferences (see Figure 1b), which occur between the multiple interreflected waves within the thin film.

Once the envelopes and tangent points are determined, the Swanepoel Method provides an algebraic approach for rapid retrieval (often in milliseconds) of $n(\lambda_{\text{tan}})$, $k(\lambda_{\text{tan}})$, and d . However, the method does not specify how to find the envelopes. One major drawback of the method is that errors in estimating the envelope propagate through the algorithm [6,7], leading to significant inaccuracies in the optical properties.

Various alternatives exist to find these envelopes, such as a modern deep learning approach [8] or the classical McClain algorithm [9]. The latter technique first assumes these points to be near the spectrum maxima and minima and then iteratively fixes them. Here, we propose a new alternative based on direct optimization. First, we identify the concave regions $[u_t^{\min}, u_t^{\max}]$, $t \in \{1, \dots, U\}$ where the lower points must reside, and the convex regions $[v_t^{\min}, v_t^{\max}]$, $t \in \{1, \dots, V\}$ where the upper points are. Observe that for any upper points $(\lambda_1^M, \lambda_2^M, \dots, \lambda_U^M)$ we identify, we can construct an approximate upper envelope using B-splines interpolation (and similarly for the lower envelope, using the lower tangent points). The upper envelope should always be greater than or equal to the transmission curve, and the lower envelope should always be less than or equal to the transmission curve. Therefore, we can formulate the following optimization problem:

$$\begin{cases} \text{minimize} & \mathcal{C}_M(\lambda_1^M, \lambda_2^M, \dots, \lambda_U^M) = \sum_{k=1}^K \text{ReLU} \left[T(\lambda_k) - T_M(\lambda_k; \lambda_1^M, \lambda_2^M, \dots, \lambda_U^M) \right], \\ \text{subject to} & \lambda_t^M \in [u_t^{\min}, u_t^{\max}], \text{ for } t \in \{1, 2, \dots, U\}. \end{cases} \quad (1a)$$

$$\begin{cases} \text{minimize} & \mathcal{C}_m(\lambda_1^m, \lambda_2^m, \dots, \lambda_V^m) = \sum_{k=1}^K \text{ReLU} \left[T_m(\lambda_k; \lambda_1^m, \lambda_2^m, \dots, \lambda_V^m) - T(\lambda_k) \right], \\ \text{subject to} & \lambda_t^m \in [v_t^{\min}, v_t^{\max}], \text{ for } t \in \{1, 2, \dots, V\}. \end{cases} \quad (1b)$$

We look for the optimal upper (or lower) tangent points by minimizing the cost function \mathcal{C}_M (or \mathcal{C}_m respectively), With the rectified linear unit function (ReLU), we effectively measure the error between the interpolated envelope (T_M) and the experimental transmittance T at all the different measured wavelengths $k \in \{1, \dots, K\}$. These two global optimization problems can be solved using the Simulated Annealing optimizer, typically in less than a minute on a conventional computer.

We have validated this methodology using fifty different simulated spectra in which the actual ground-truth envelopes are known. The root mean square error was found to be 0.25% for the upper envelope and 0.15% for the lower envelope. Our method competes with state-of-the-art alternatives and generally provides similar or lower errors, albeit with a slightly higher computational cost. The method has also been tested with a real sample of amorphous silicon analyzed in [10], resulting in errors of 0.6% for the upper envelope and 0.5% for the lower envelope (still within an acceptable range, below 1%).

It should be emphasized that this is a work in progress. Further research will focus on validation with additional experimental measurements and a systematic comparison with existing state-of-the-art methodologies.

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